

**Notice of References Cited**

Application/Control No.

10/552,414

Applicant(s)/Patent Under

Reexamination

MIKI ET AL.

Examiner

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Art Unit

1793

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,117,389	09-2000	Nabeshima et al.	420/83
	B	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

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	P	JP 2003-103,349	04-2003	JP	-----	-----
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	X	

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